



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **IBARA, Yoshikazu et al.**

Group Art Unit: 2823

Serial No.: **09/892,893**

Examiner: **COLEMAN, William D.**

Filed: **June 28, 2001**

P.T.O. Confirmation No.: **1585**

For: **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES WITH
SILICIDE FILMS THEREON**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: **July 25, 2003**

Sir:

Please amend the above-captioned patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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